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Bib Data Sheet

CONFIRMATION NO. 6774

<b>SERIAL NUMBER</b> 10/552,262	<b>FILING OR 371(c) DATE</b> 10/05/2005 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 33082M275
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

YFIU

This application is a 371 of PCT/JP04/05643 04/20/2004

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

YEIC

JAPAN 2003-117664 04/22/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

06/20/2006

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 9	<b>TOTAL CLAIMS</b> 15	<b>INDEPENDENT CLAIMS</b> 2
Verified and Acknowledged	Examiner's Signature Initials				

## ADDRESS

441

## TITLE

Method for removing silicon oxide film and processing apparatus

<b>FILING FEE RECEIVED</b> 1410	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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